



PATENT
Attorney Docket No. 98124X205843

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9/12/02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Wang et al.

Application No. 09/636,246

Art Unit: 1765

Examiner: Charlotte A. Brown

Filed: August 10, 2000

For: POLISHING SYSTEM WITH
STOPPING COMPOUND AND
METHOD OF ITS USE

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TECHNOLOGY CENTER 1100

RESPONSE TO OFFICE ACTION

Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

In response to the Office Action dated May 31, 2002, please enter the following amendments and consider the following remarks.

AMENDMENTS

IN THE CLAIMS:

Please cancel claims 32-35, 45, and 46 without prejudice or disclaimer of the subject matter contained therein.

REMARKS

Information Disclosure Statement

Applicants have received a copy of the Examiner-initialed Form PTO-1449 identifying references AA-AP, but noted that reference AM has not been initialed by the Examiner. Applicants respectfully request confirmation of the consideration of reference AM by return copy of the Examiner-initialed Form PTO-1449 showing the Examiner's initials next to the identification of reference AM.

The Pending Claims

Claims 1-31, 36-44, and 47-51 are currently pending. All of the pending claims are directed to a system for polishing one or more layers of a multi-layer substrate that includes a first metal layer and a second layer comprising (i) a liquid carrier, (ii) at least one oxidizing agent, (iii) at least one polishing additive that increases the rate at which the system polishes